

AMENDMENT TRANSMITTAL LETTER (Large Entity)

Applicant(s): Kei-Yu Ko

Docket No.

11675.114

Serial No.
08/846,671Filing Date
April 30, 1997Examiner
George A. GoudreauGroup Art Unit
1763

UNDOPED SILICON DIOXIDE AS ETCH STOP FOR SELECTIVE ETCH OF DOPED SILICON DIOXIDE

TO THE ASSISTANT COMMISSIONER FOR PATENTS:

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated and is transmitted as shown below.

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SEP 25 2001

CLAIMS AS AMENDED

TC 1700

	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE
TOTAL CLAIMS	45 -	54 =	0 x	\$18.00	\$0.00
INDEP. CLAIMS	X 8 -	8 =	0 x	\$80.00	\$0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					\$0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0.00

- ☒ No additional fee is required for amendment.
- ☐ Please charge Deposit Account No. _____ in the amount of _____
A duplicate copy of this sheet is enclosed.
- ☐ A check in the amount of _____ to cover the filing fee is enclosed.
- ☒ The Commissioner is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 23-3178
A duplicate copy of this sheet is enclosed.
- ☒ Any additional filing fees required under 37 C.F.R. 1.16.
- ☒ Any patent application processing fees under 37 CFR 1.17.

Dated: September 19, 2001



022901

PATENT TRADEMARK OFFICE

I certify that this document and fee is being deposited on _____ with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.

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PATENT APPLICATION
Docket No. 11675.114

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Kei-Yu Ko

Serial No.:

08/846,671

Filed:

April 30, 1997

For:

UNDOPED SILICON DIOXIDE AS ETCH
STOP
FOR SELECTIVE ETCH OF
DOPED SILICON DIOXIDE

Examiner:

George A. Goudreau

Group Art
Unit 1763

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TC 1700

AMENDMENT "D" AND RESPONSE

The Honorable Commissioner of Patents
and Trademarks
Washington, D. C. 20231

Sir:

In response to the Office Action dated on June 19, 2001 (the "Office Action"),
Applicant submits this Amendment "D" and Response. Please amend the above-identified
application as follows:

IN THE CLAIMS:

CLEAN VERSION OF THE PENDING CLAIMS Under 37 C.F.R. § 1.121(c)(3):

Please amend the claims as indicated below so that the following list presents a clean version
of the entire set of pending claims.

Amendment "D" and Response
Serial No. 08/846,671